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Bib Data Sheet

CONFIRMATION NO. 5293

<b>SERIAL NUMBER</b> 09/755,673	<b>FILING DATE</b> 01/05/2001 <b>RULE</b>	<b>CLASS</b> 438	<b>GROUP ART UNIT</b> 2812	<b>ATTORNEY DOCKET NO.</b> M122-1531
<b>APPLICANTS</b> Leonard Forbes, Corvallis, OR; Kie Y. Ahn, Chappaqua, NY; Jerome Michael Eldridge, Los Gatos, CA;				
<b>** CONTINUING DATA *****</b> None K.N. Micron Technology, Inc.				
<b>** FOREIGN APPLICATIONS *****</b> None K.N.				
<b>IF REQUIRED, FOREIGN FILING LICENSE</b> <b>GRANTED ** 02/21/2001</b>				
Foreign Priority claimed <input type="checkbox"/> yes <input checked="" type="checkbox"/> no 35 USC 119 (a-d) conditions <input type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after allowance met Verified and <u>Khuong Nguyen</u> K.N. Acknowledged Examiner's Signature Initials		<b>STATE OR COUNTRY</b> OR	<b>SHEETS DRAWING</b> 6	<b>TOTAL CLAIMS</b> 34
				<b>INDEPENDENT CLAIMS</b> 3
<b>ADDRESS</b> 021567				
<b>TITLE</b> Methods of forming capacitor structures, and capacitor structures				
<b>FILING FEE RECEIVED</b> 962	<b>FEES:</b> Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees ( Filing ) <input type="checkbox"/> 1.17 Fees ( Processing Ext. of time ) <input type="checkbox"/> 1.18 Fees ( Issue ) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit	